OIPE
MAY 18 2005
PATENT & TRADEMARK OFFICE
JC98

Docket No. 740819-1030

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Kenshi KANEGAE et al.	)	Group Art Unit: 1765
Application No. 10/679,464	)	Examiner: Kin Chan Chen
Filed: October 7, 2003	)	Confirmation No. 5297
For: ETCHING METHOD, SEMICONDUCTOR AND FABRICATING METHOD FOR THE SAME	)	Date: May 18, 2005

AMENDMENT

Mail Stop **RCE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 18, 2005 and to the personal Examiner Interview conducted May 5, 2005, please consider the remarks and amendments in connection with the above-identified application as follows.